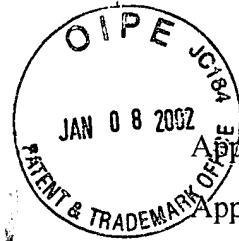


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: P. LaCour et al. Attorney Docket No.: MEGC116848

Application No.: 09/781,128

Group Art Unit: 2122

Filed: February 9, 2001

Title: DATA MANAGEMENT METHOD FOR RETICLE/MASK WRITING

INFORMATION DISCLOSURE STATEMENT

Seattle, Washington 98101

October 24, 2001

TO THE COMMISSIONER FOR PATENTS:

Applicants are aware of the information listed in the attached form that may be material to the prosecution of the above-identified patent application.

1. Copies of the listed patents, publications, and other information are enclosed for the Examiner's use.
2. Pursuant to 37 C.F.R. § 1.97(b), this Information Disclosure Statement is being filed within three months of the filing date of the national application (other than a CPA), within three months of the date of entry of the national stage as set forth in 37 C.F.R. § 1.491 in an international application, before the mailing date of a first Office Action on the merits, or before the mailing date of a first Office Action after the filing of an RCE.
3. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16, 1.17 and 1.18 which may be required during the entire pendency of the application, or credit any overpayment, to Deposit Account No. 03-1740. This

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authorization also hereby includes a request for any extensions of time of the appropriate length required upon the filing of any reply during the entire prosecution of this application.

Respectfully submitted,

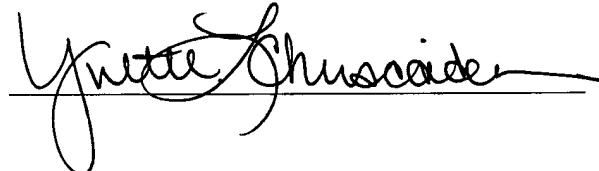
CHRISTENSEN O'CONNOR
JOHNSON KINDNESS^{PLLC}



Rodney C. Tullett
Registration No. 34,034
Direct Dial No. 206.695.1730

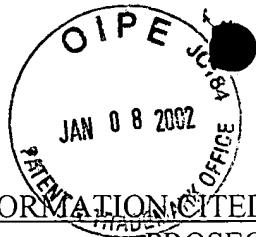
I hereby certify that this correspondence is being deposited with the U.S. Postal Service in a sealed envelope as first class mail with postage thereon fully prepaid and addressed to the Commissioner for Patents, Washington, D.C. 20231, on the below date.

Date: October 24, 2007



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INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL TO THE PROSECUTION OF THE SUBJECT APPLICATION

Applicant: P. LaCour et al

Attorney Docket No. MEGC116848

Application No.: 09/781,128

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Title: DATA MANAGEMENT METHOD FOR RETICLE/MASK WRITING

U.S. PATENT DOCUMENTS

*Examiner	Document			
Initial	ID	No.	Date	Name
<u>C.C.</u>	U1	5,050,091	09/17/1991	Rubin

FOREIGN PATENT DOCUMENTS

None

OTHER INFORMATION
(Including Author, Title, Date, Pertinent Pages, Etc.)

None

Examiner

Date Considered

Christopher A.

8/8/03

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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